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# First-principles study of vacancy defects at interfaces between monolayer MoS<sub>2</sub> and Au

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The performance of  $MoS_2$  based devices is closely related to the quality and defect morphology of the monolayer  $MoS_2$  deposited on metal. First-principles calculations were performed to investigate the vacancy effects of  $Au-mMoS_2$  contact. Four possible S-vacancy and a Mo-vacancy were considered in our calculations. Energetic studies show that S-vacancies are easier to form than Mo-vacancy in  $Au-mMoS_2$  contact, while S-vacancy (hollow site at interface,  $V_{S4}$ ) has the lowest formation energy under Mo-rich environments. Electron and charge redistribution analysis of defective  $Au-mMoS_2$  contact indicate that the lower contact resistance and higher electron injection efficiency of defective  $Au-MoS_2$  contact than perfect ones. Notably, the S-vacancy at top layer showed better electronic performance than that at bottom layer of monolayer  $MoS_2$  in the contact. High quality n-type  $Au-mMoS_2$  contact can therefore be expected through defect engineering.

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#### Introduction

The discovery of graphene has upended the traditional understanding of two-dimensional structures, however, the zerobandgap nature of graphene has limited their digital logic applications.<sup>1</sup> Transition-metal dichalcogenides (TMDs) with tunable bandgaps like MoS<sub>2</sub>, WSe<sub>2</sub>, etc. have emerged to be potential materials for digital logic applications in spite of their inferior carrier mobility.<sup>2</sup> Bulk MoS<sub>2</sub> has a graphene-like layered structure, where the S-Mo-S slabs are stacked together via weak van der Waals (vdW) interlayer interaction<sup>3</sup> Few-layer MoS<sub>2</sub> can therefore be mechanically exfoliated<sup>4</sup> and their bandgaps vary with the number of layers.5 Monolayer MoS2 has a direct bandgap of 1.81 eV,6 which endows many excellent properties for nanoelectronics. Monolayer MoS<sub>2</sub> has been regarded as a highly competitive candidate for field-effect transistors (FETs) with a high on/off ratio, and photodetectors based on MoS<sub>2</sub> have been intensively investigated.7-9

A metal contact is required to inject appropriate types of carriers into the host materials for an actual electronic or photoelectronic device using 2D materials as the semiconducting channel.<sup>10</sup> Abundant researches<sup>11–14</sup> have shown that the properties for 2D materials based devices can be tuned by substrate selections through interlayer interaction. Copper is the most well-studied metal contact for MoS<sub>2</sub> based devices. Experimentally, Kim D. *et al.* prepared monolayer MoS<sub>2</sub> islands on a copper surface at moderate growth conditions through

sulfur loading of the substrate using thiophenol *via* e-beam evaporation (physical vapor deposition), and obtained high quality MoS<sub>2</sub> monolayer with atomic ordering.<sup>15</sup> Later on, first-principles calculations were demonstrated by Le D. *et al.* to investigate the geometric and electronic structures of mono-layer MoS<sub>2</sub> on Cu(111).<sup>16</sup> They predicted chemical interaction between monolayer MoS<sub>2</sub> and the Cu surface atoms instead of physical adsorption.

Au has shown privilege conducting properties, ductility and better interlayer interaction comparing to Cu, is expected to be ideal substrate materials for fabricating monolayer MoS2.17 Large area single-layer MoS<sub>2</sub> has been successfully synthesized on the Au(111) surface by physical vapor deposition (PVD) in ultrahigh vacuum.<sup>18</sup> It is interesting to note that B. Radisavljevic et al. used a hafnium oxide gate dielectric to demonstrate a room-temperature single-layer MoS<sub>2</sub> mobility of at least 200 cm<sup>2</sup> V<sup>-1</sup> s<sup>-1</sup>, similar to that of graphene nanoribbons, and demonstrated transistors with room-temperature current on/off ratios of  $1 \times 10^8$  and ultralow standby power dissipation, where Au as the electrode of the transistors. However, calculations by Popov et al.<sup>19</sup> suggested that it is rather inefficient for electron injection from Au into single-layer MoS2 while forming a tunnel barrier at the interface.<sup>20</sup> The inefficiency can be caused by the pristine monolayer MoS<sub>2</sub> model adopted in their calculations. However, experimental investigation speculated that the low contact resistance between Au and monolayer MoS2 was due to defects of pristine monolayer MoS<sub>2</sub> during the preparation process.21

The performance of devices is closely related to the quality and defect morphology of the monolayer  $MoS_2$  since defects are evitable during the preparation process. It has been well documented that vacancies in monolayer  $MoS_2$  can have significant

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influence on the electronic and magnetic properties.<sup>22-26</sup> In addition, vacancies can introduce dangling bonds at the interface between the monolayer MoS<sub>2</sub> and Au, which can enhance adsorption capacity and improve the carrier mobility.<sup>10</sup> Su et al.<sup>17</sup> studied the effects of vacancies in monolayer MoS<sub>2</sub> on electronic structure and electronic properties of Au-MoS<sub>2</sub> contact and suggest that defective Au-mMoS<sub>2</sub> top contacts have lower contact resistance and higher electron injection efficiency, whereas Au-MoS<sub>2</sub> contact with Mo-vacancy shows chemisorption interface with ohmic character. Displacement reaction by reactive metals is energetically favourable, which should act to lower resistance contacts.27 However, their researches ignored the stability of the model. The mismatch between monolayer MoS<sub>2</sub> and Au remains large relatively, which may lead to deviations. Only one possible S-vacancy site was concerned in their model, further demonstrations for vacancy effects in Au-MoS<sub>2</sub> system are required.

In this study, first-principles calculations are performed to further illustrate the interface effect induced by intrinsic vacancies. Interface model of Au–mMoS<sub>2</sub> with a relatively small mismatch is therefore built to investigate the electronic structure and electronic properties of the system of Au–mMoS<sub>2</sub> contact. These studies may pave the ways for optimal design of MoS<sub>2</sub>-based electronic devices.

#### Computational details

First principles calculations were performed based on the density functional theory (DFT) with local density approximation (LDA). The geometry optimizations and electronic structure calculations are performed with the projector augmented wave (PAW) pseudopotential<sup>28</sup> and the plane-wave cutoff energy is set to be 450 eV, implemented in the Vienna ab initio simulation package (VASP) code.<sup>29,30</sup> DFT-D2 scheme is included to describe the vdW interactions. The maximum Hellmann-Feynman force between each atom during geometry optimization is less than 0.02 eV Å  $^{-1}$  , and energies are converged to within 1.0  $\times$  10  $^{-5}$  eV per atom. A 5  $\times$  5  $\times$  1 k-mesh based on gamma-centered scheme is applied for relaxation calculations. A vacuum slab of 15 Å is added in monolayer and interface models to avoid spurious interactions between the individual structures. All the calculations were performed under same relaxation criteria and spin-polarized calculations were considered for all defective models.

#### Results and discussion

A ( $\sqrt{3} \times \sqrt{3}$ ) supercell of monolayer MoS<sub>2</sub>, consisting of 3 Mo atoms and 6 S atoms with one Mo layer arrays between two S layers in a trigonal prismatic layout, is adopted in this study.

The calculated lattice constant of monolayer is 3.160 Å, which is in excellent consistent with the experimental value (3.161 Å).<sup>31</sup> and the calculated average Mo–S bond length is 2.374 Å. The calculated band gap for pristine monolayer MoS<sub>2</sub> is 1.87 eV, as illustrated in Fig. 1b, agreeing well with the experimental value (1.90 eV).<sup>6</sup> The schematic of metal–mMoS<sub>2</sub> transistor device is shown in Fig. 2a. Testified four layers of Au

atoms were chosen to simulate the metal contact and a 2 ( $\sqrt{3} \times \sqrt{3}$ ) monolayer MoS<sub>2</sub> (see Fig. 1a) was absorbed on one side of the Au (111) surfaces, as shown in Fig. 2b and c. The lattice constants of Au (111) surface are kept fixed to simulate the experimental deposition environment, with a = b = 3.122 Å. Fig. 3a–e show the models of Au–mMoS<sub>2</sub> with five concerned vacancies after structural relaxation.

The structural effects for different types of vacancies on the Au-mMoS<sub>2</sub> can be evaluated by calculating average bond lengths of Mo–S and atomic layer spacing  $d_{S-Au}$  (as denoted in Fig. 2), which are summarized in Table 1. It can be found that the covalent bond length of Mo–S is slightly increased when contact with Au comparing to pristine monolayer. Moreover, it is obvious that both bond lengths and  $d_{S-Au}$  (see Fig. 2) with defects are shorter than pristine systems. The shrink can be owed to the surrounding atoms move outwards when a vacancy forms.<sup>23</sup> The formation of either Mo or S vacancy can facilitate the adsorption of gold with monolayer MoS<sub>2</sub> since interface distances are generally decreased.

The structural stability of different vacancies defects can be calculated using the following equation,<sup>22</sup>

$$E_{\rm f} = E_{\rm vacancy} - E_{\rm perfect} + \sum N_{\rm i} \times \mu_{\rm i}$$

here,  $E_{\text{vacancy}}$  and  $E_{\text{perfect}}$  stand for the total energy of the supercell with and without vacancy, respectively.  $N_i$  is the numbers of type i that have removed from the supercell when vacancy is created.  $\mu_i$  represents the relevant chemical potentials of these atoms. Due to the thermodynamic equilibrium, the chemical of Mo and S must satisfy the stability condition for MoS<sub>2</sub>. Therefore, the upper limit of Mo chemical potential is given by the energy of one Mo atom in bulk molybdenum, while the lower limit of Mo chemical potential corresponds to the energy difference between the monolayer MoS<sub>2</sub> unit cell and a S<sub>2</sub> molecule.<sup>32</sup> Hence, the extreme S-rich condition is therefore taken as the energy of one S atom in bulk sulfur. The formation energies of monolayer MoS<sub>2</sub> with vacancy can be expressed as a function of S chemical potential, over a wide range of experimental conditions from Mo-rich to S-rich, are plotted in Fig. 4.

The slopes of the energy profiles are proportional to the excess/deficit of S atoms in the defects. It can be seen that with the increase of the sulfur content, the formation energy of a Movacancy in the Au-mMoS<sub>2</sub> contact decreases linearly. This



Fig. 1 (a) The atomic structures of monolayer MoS<sub>2</sub> from top view and side view, the dotted lines represent the calculated  $\sqrt{3} \times \sqrt{3}$  cell. (b) Band structure and DOS of monolayer MoS<sub>2</sub> in a  $\sqrt{3} \times \sqrt{3}$  cell.



Fig. 2 (a) 2D cross-section schematic of metal–mMoS<sub>2</sub> transistor devices; structural diagram of Au–mMoS<sub>2</sub> contact: (b) the top view; (c) the side view,  $d_{S-Au}$  represents the vertical average distance monolayer MoS<sub>2</sub> and Au.

implies that Mo-vacancy is more likely to form under S-rich environment. Similarly, the Au–mMoS<sub>2</sub> with a S-vacancy can be more stable under Mo-rich condition. In addition, the formation energies of four types of S-vacancies can be relatively lower than that of Mo-vacancy under a wide range of sulfur chemical potentials. In most cases, it is easier to form S-vacancy in Au–mMoS<sub>2</sub> top contact than Mo-vacancy. V<sub>S4</sub> at interface hollow site has the lowest formation energy among the four concerned S-vacancies under Mo-rich environments. The variations in formation energies of a (Mo or S) vacancy in the Au– mMoS<sub>2</sub> contact are consistent with those of a (Mo or S) vacancy

 $\label{eq:table_$ 

Structure	Mo-S (Å)	$d_{ ext{S-Au}}\left( ext{\AA} ight)$
$mMoS_2$	2.378	_
Au-mMoS <sub>2</sub>	2.432	2.820
V <sub>S1</sub>	2.387	2.811
V <sub>S2</sub>	2.387	2.814
V <sub>S3</sub>	2.386	2.811
V <sub>S4</sub>	2.387	2.808
V <sub>Mo</sub>	2.408	2.443



Fig. 4 Formation energies of different vacancies as functions of sulfur chemical potential, plotted in the range  $-1.3 \text{ eV} \le \Delta \mu_s \le 0 \text{ eV}$ , corresponding to the formation of bulk Mo and bulk alpha-S.

in monolayer  $MoS_2$ .<sup>31</sup> The actual experimental conditions of growth for  $MoS_2$  deposited on gold is assumed to be the Mo-rich region since experimental results have shown a sub-



Fig. 3 Schematic diagram of Au-mMoS<sub>2</sub> top contact with (a)–(d) S-vacancy and (e) Mo-vacancy:  $V_{S1}$ ,  $V_{S2}$ ,  $V_{S3}$ ,  $V_{S4}$  and  $V_{Mo}$ ; (f) corresponds to the top view of (a) and (c); (g) corresponds the top view of (b) and (d); and (h) is the top view of (e).



Fig. 5 Calculated PDOS of (a) perfect Au-mMoS<sub>2</sub> contact, (b)  $V_{Mo'}$  (c)  $V_{S1'}$  (d)  $V_{S2'}$  (e)  $V_{S3}$ , and (f)  $V_{S4}$ . The fermi levels are set at zero level as denoted by dashed grey lines.

stoichiometric Mo/S ratio higher than 0.5, suggesting a loss of S atoms.<sup>33</sup> Formation energies for double S-vacancies (V<sub>2S</sub>) are calculated using the same equation. Five different configurations of V<sub>2S</sub> with various vacancy distances are considered. The calculated formation energy of V<sub>2S</sub> is roughly twice of a single

 $V_{\rm S}$ , suggesting weak tendency of dimerization of S-vacancies under the Mo-rich conditions.

The partial density of states (PDOS) projection onto Au, S and Mo atom orbits are presented in Fig. 5a–f for the perfect and defective Au–mMoS<sub>2</sub> contact ( $V_{Mo}$ ,  $V_{S1}$ ,  $V_{S2}$ ,  $V_{S3}$ , and  $V_{S4}$ ) to



Fig. 6 Band structure of  $Au-mMoS_2$  and  $Au-mMoS_2$  with detects. (a) Represents perfect  $Au-mMoS_2$ ; (b)–(f) correspond to  $V_{S1}$ ,  $V_{S2}$ ,  $V_{S3}$ ,  $V_{S4}$  and  $V_{Mo}$ , respectively. Fermi level is at zero energy; the grey lines and red dotted lines represent the total band structure and contributions from  $MoS_2$ , respectively.



Fig. 7 Contour plots of total charge density of  $Au-mMoS_2$  contact: (a) perfect  $Au-MoS_2$  contact, (b)–(e) defective  $Au-MoS_2$  contact with various S-vacancy. (f) Defective  $Au-MoS_2$  contact with a Mo-vacancy.

investigate the effect of vacancies on the electronic properties. We selected the Au atoms at the interface to eliminate the influence of the Au atoms in the bulk phase. It can be found that the top of the valence bands and the bottom of the conduction bands of monolayer  $MOS_2$  are dominated by the hybridization of anti-bonding and bonding between  $Mo_4d$  and  $S_3p$  states. Upon contact with Au, both  $Mo_4d$  and  $S_3p$  states of monolayer  $MOS_2$  (in Fig. 1b) are shifted almost 0.3 eV in the direction of negative axis and spread across the original band gap of pristine monolayer  $MOS_2$ . Besides, Fermi level is mainly occupied by  $Mo_4d$  states, where PDOS corresponds to a low carrier density. No obvious overlap of the concerned interfacial orbitals can be found near the  $E_{\rm fr}$ , indicating weak bonding between interfacial atoms. A physisorption of Au/MoS<sub>2</sub> interface is predicted.

Defect energy levels can be introduced when there is a vacancy. Strong interaction between S\_3p and Au\_5d states is observed in Au-mMoS<sub>2</sub> contact with a Mo-vacancy, (Fig. 5b) which implies a higher electron injection efficiency compared to a perfect Au-mMoS<sub>2</sub> contact. Furthermore, some peaks of the PDOS occur near the top of original valence bands of the monolayer MoS<sub>2</sub>, indicating the defective contact is p-type. Fig. 5c-f illustrate the PDOS of Au-mMoS<sub>2</sub> contact with different types of S-vacancies. There is no evident difference of the PDOS when S-vacancy locates in the same atomic layer. However, stronger hybridization between S\_3p and Au\_5d orbitals of S-vacancy in top S layer (V<sub>S1</sub> or V<sub>S2</sub>) is found than that of vacancies in bottom layer of monolayer  $MoS_2$  ( $V_{S3}$  or  $V_{S4}$ ). A n-type Au-mMoS<sub>2</sub> contact is expected with all kinds of S-vacancies.

Band structure analysis on selected atoms of perfect and defective Au-mMoS<sub>2</sub> contact are shown in Fig. 6. Despite the energy bands of MoS<sub>2</sub> and Au are mostly hybridized together, the majority bands of the MoS<sub>2</sub> can be recognized clearly. The monolayer MoS<sub>2</sub> still presents semiconducting nature in the perfect contact as shown in Fig. 6a, further confirming the physisorption of the Au/MoS2 interface. However, the Fermi level of the Au-mMoS<sub>2</sub> generally moves upward and the bad gap slightly reduces comparing with single monolayer MoS<sub>2</sub>. Fig. 6b–e present the band structures of four types of Au–mMoS<sub>2</sub> contact with S-vacancy. It is obvious that defect bands can be introduced and band gap shall be reduced, therefore stronger interaction between Au and monolayer MoS<sub>2</sub> than pristine contact is expected. Fermi levels of the defective contact always lie in the band gap region of MoS<sub>2</sub>, contributing to the formation of Schottky barrier heights, which can be evaluated by the energy differences between the conduction band minimum and the Fermi levels. V<sub>S1</sub> and V<sub>S2</sub> located at the top layer are predicted to have smaller band gap and lower Schottky barrier heights at interface than the bottom vacancies due to stronger hybridization of interfacial Au and MoS<sub>2</sub>. Au-mMoS<sub>2</sub> contact with a Mo-vacancy has a narrower and more active band gap than S-vacancies as shown in Fig. 6f and better chemical contact with substrate is therefore expected.

To further illustrate the interfacial bonding and electronic properties, the total electron distributions of the Au–mMoS<sub>2</sub> contacts were plotted in Fig. 7. Electron redistributions can be observed around the defective areas, which result in stronger binding between the monolayer and substrate. The electron accumulations around interfacial S and Au atoms in defective contacts imply a transition from physisorption into chemisorption and formation of weak Au–S covalent bonds. The Au–S bonds in system with Mo-vacancy is more covalent than others, consisted with their band structure analysis. The defective systems can therefore exhibit higher electron injection efficiency than pristine ones.

#### Conclusions

In summary, the interfacial properties of Au–mMoS<sub>2</sub> contact with possible vacancies were systematically investigated through first-principles calculations. Based on the afore discussed results, we found that the formation energies of four types of S-vacancy are generally lower than Mo-vacancy over a wide range of S chemical potential. The actual experimental growth condition is assumed to be Mo-rich where S-vacancies are more likely to form. Density of states, band structures and electron density of states analysis of the systems indicate a lower contact resistance and higher electron injection efficiency of defective Au–MoS<sub>2</sub> contacts than perfect one. Notably, the S-vacancy locates on the top layer of monolayer MoS<sub>2</sub> shows better performance than that on the bottom layer. Mo-vacancy is beneficial for obtaining high quality p-type Au–mMoS<sub>2</sub> contact, whereas n-type contacts can be achieved by S-vacancies. These findings can bring new ideas for design and fabrication of novel nanoelectronics devices with monolayer MoS<sub>2</sub> through defect engineering.

### Conflicts of interest

There are no conflicts to declare.

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#### References

- 1 V. Singh, D. Joung, L. Zhai, S. Das, S. I. Khondaker and S. Seal, *Prog. Mater. Sci.*, 2011, **56**, 1178–1271.
- 2 D. Saha and S. Mahapatra, Appl. Phys. Lett., 2016, 108, 253106.
- 3 M. Kin Fai, K. He, J. Shan and T. F. Heinz, *Nat. Nanotechnol.*, 2018, 7, 494–498.
- 4 K. S. J. Novoselov, D. Schedin, F. Booth, T. J. Khotkevich, V. V. Morozov, S. V. Morozov and A. K. Geim, *Proc. Natl. Acad. Sci. U. S. A.*, 2005, **102**, 10451–10453.
- 5 J. Mann, Q. Ma, P. Odenthal, M. Isarraraz, D. Le, E. Preciado, D. Barroso, K. Yamaguchi, G. Palacio, A. Nguyen, T. N. Tai, M. Wurch, A. Nguyen, V. Klee, S. Bobek, D. Sun, T. Heinz, T. Rahman, R. Kawakami and L. Bartels, *Adv. Mater.*, 2014, 26, 1399–1404.
- 6 K. Mak, C. Lee, J. Hone, J. Shan and T. Heinz, *Phys. Rev. Lett.*, 2010, **105**, 136805.
- 7 W. Zhang, J.-K. Huang, C.-H. Chen, Y.-H. Chang, Y.-J. Cheng and L. Li, *Adv. Mater.*, 2013, **25**, 3456–3461.
- 8 X. Wang, P. Wang, J. Wang, X. Zhou, N. Guo, H. Huang, S. Sun, H. Shen, T. Lin, M. Tang, L. Liao, A. Jiang, J. Sun, X. Meng, X. Chen, W. Lu and J. Chu, *Adv. Mater.*, 2015, 27, 6575–6581.
- 9 Y. Chen, X. Wang, P. Wang, H. Huang, G. Wu, B. Tian, Z. Hong, Y. Wang, S. Sun, H. Shen, J. Wang, W. Hu, J. Sun, X. Meng and J. Chu, ACS Appl. Mater. Interfaces, 2016, 8, 32083–32088.
- 10 J. Kang, W. Liu, D. Sarkar, D. Jena and K. Banerjee, *Phys. Rev. X*, 2014, **4**, 031005.
- 11 H. Zhong, R. Quhe, Y. Wang, Z. Ni, M. Ye, Z. Song, Y. Pan, J. Yang, L. Yang and M. Lei, *Sci. Rep.*, 2016, **6**, 21786.

- 12 A. Chanana and S. Mahapatra, J. Appl. Phys., 2014, 116, 204302.
- Y. Pan, Y. Wang, M. Ye, R. Quhe, H. Zhong, Z. Song, X. Peng,
   D. Yu, J. Yang and J. Shi, *Chem. Mater.*, 2016, 28, 2109.
- 14 C. M. Smyth, R. Addou, S. Mcdonnell, C. L. Hinkle and R. M. Wallace, *J. Phys. Chem. C*, 2016, **120**, 14719–14729.
- 15 D. Kim, D. Sun, W. Lu, Z. Cheng, Y. Zhu, D. Le, T. S. Rahman and L. Bartels, *Langmuir*, 2011, 27, 11650–11653.
- 16 D. Le, D. Sun, W. Lu, L. Bartels and T. S. Rahman, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2012, **85**, 075429.
- 17 J. Su, N. Li, Y. Zhang, L. Feng and Z. Liu, *AIP Adv.*, 2015, 5, 077182.
- 18 S. S. Grønborg, S. Ulstrup, M. Bianchi, M. Dendzik, C. E. Sanders, J. V. Lauritsen, P. Hofmann and J. A. Miwa, *Langmuir*, 2015, **31**, 9700–9706.
- 19 I. Popov, G. Seifert and D. Tománek, *Phys. Rev. Lett.*, 2012, 108, 156802.
- 20 B. Radisavljevic, A. Radenovic, J. Brivio, V. Giacometti and A. Kis, *Nat. Nanotechnol.*, 2011, 6, 147–150.
- 21 C. Maurel, F. Ajustron, R. Péchou, G. Seine and R. Coratger, *Surf. Sci.*, 2006, **600**, 442–447.
- 22 Y. Wang, L.-T. Tseng, P. P. Murmu, N. Bao, J. Kennedy, M. Ionesc, J. Ding, K. Suzuki, S. Li and J. Yi, *Mater. Des.*, 2017, **121**, 77–84.
- 23 L.-p. Feng, J. Su and Z.-t. Liu, J. Alloys Compd., 2014, 613, 122–127.
- 24 Y. Han, J. Zhou and J. Dong, *Appl. Surf. Sci.*, 2015, **346**, 470–476.
- 25 D. Ma, W. Ju, T. Li, X. Zhang, C. He, B. Ma, Y. Tang, Z. Lu and Z. Yang, *Appl. Surf. Sci.*, 2016, **364**, 181–189.
- 26 X. Zhao, C. Xia, T. Wang and X. Dai, *Solid State Commun.*, 2015, **220**, 31–35.
- 27 D. Liu, Y. Guo, L. Fang and J. Robertson, *Appl. Phys. Lett.*, 2013, **103**, 183113.
- 28 G. Kresse and D. Joubert, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1999, **59**, 1758–1775.
- 29 G. Kresse, J. Non-Cryst. Solids, 1995, 192-193, 222-229.
- 30 G. Kresse and J. Furthmüller, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 1996, 54, 11169–11186.
- 31 B. Schonfeld, J. J. Huang and S. C. Moss, *Acta Crystallogr.,* Sect. B: Struct. Sci., 1983, **39**, 404–407.
- 32 M. V. Bollinger, K. W. Jacobsen and J. K. Nørskov, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2003, **67**, 085410.
- 33 M. Donarelli, F. Bisti, F. Perrozzi and L. Ottaviano, *Chem. Phys. Lett.*, 2013, **588**, 198–202.